



FW AF

Docket No.: R2180.0193/P193
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Naohiro Ueda

Application No.: 10/801,838

Confirmation No.: 3147

Filed: March 17, 2004

Art Unit: 2814

For: SEMICONDUCTOR APPARATUS AND
METHOD OF MANUFACTURING THE
SAME

Examiner: A. Kalam

DO NOT ENTER: /AK/

06/27/2008

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated April 14, 2008, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.